



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

June 25, 2026

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

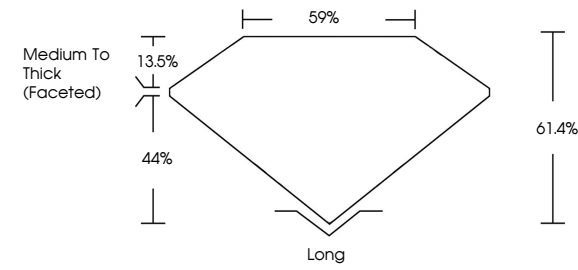
INSCRIPTION(S)

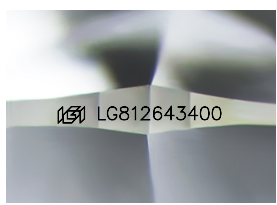
COMMENTS: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG812643400

Report verification at [igi.org](#)

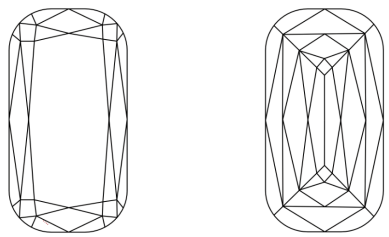
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

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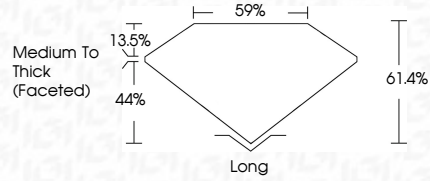
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LG812643400

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PROPORTIONS



COLOR

CLARITY

LABORATORY GROWN DIAMOND REPORT

June 25, 2026

IGI Report No LG812643400

CUSHION MIXED CUT

12.21 X 8.21 X 5.04 MM

4.56 CARATS

E

VVS 2

EXCELLENT

EXCELLENT

NONE

IGI LG812643400

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

IGI



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June 25, 2026

IGI Report No LG812643400

CUSHION MIXED CUT

12.21 X 8.21 X 5.04 MM

4.56 CARATS

E

VVS 2

61.4%

59%

Medium To Thick (Faceted)

Long

EXCELLENT

EXCELLENT

NONE

IGI LG812643400

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